PTO/SB/01A (08-03)

Attorney Docket No.: 021653-000400US Client Ref. No.: I-02-023

DECLARATION (37 CFR 1.63) FOR UTILITY OR DESIGN APPLICATION USING AN APPLICATION DATA SHEET (37 CFR 1.76)

Title of Invention	n METHOD AND STRUCTURE TO FORM CAPACITOR IN COPPER DAMASCENE PROCESS FOR INTEGRATED CIRCUIT DEVICES						
As the below named inventor(s), I/we declare that:							
This declaration is directed to:							
	\boxtimes	The attached application, or					
1		Application No. , filed on ,					
		as amended on (if applical	ble);				
I/we believe that I/we am/are the original and first inventor(s) of the subject matter which is claimed and for which a patent is sought;							
I/we have reviewed and understand the contents of the above-identified application, including the claims, as amended by any amendment specifically referred to above;							
I/we acknowledge the duty to disclose to the United States Patent and Trademark Office all information known to me/us to be material to patentability as defined in 37 CFR 1.56, including for continuation-in-part applications, material information which became available between the filing date of the prior application and the national or PCT International filing date of the continuation-in-part application.							
All statements made herein of my/our own knowledge are true, all statements made herein on information and belief are believed to be true, and further that these statements were made with the knowledge that willful false statements and the like are punishable by fine or imprisonment, or both, under 18 U.S.C. 1001, and may jeopardize the validity of the application or any patent issuing thereon.							
FULL NAME OF INVEN	ITOR(S)						
Inventor 1 Chi Ho	ng Pai		Date:	2003, 12.29			
Signature:	色垒	· · · · · · · · · · · · · · · · · · ·	Citizen of:	Republic of China			
Inventor 2			Date:				
Signature:			Citizen of:				
Inventor 3			Date:				
Signature:			Citizen of:				
Additional inventors are	e being n	amed on additional form(s) attached	d hereto.				

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POWER OF ATTORNEY and CORRESPONDENCE ADDRESS INDICATION FORM

Application Number				
Filing Date				
First Named Inventor	Pai, Chi Hong			
Title	METHOD AND STRUCTURE TO FORM CAPACITOR IN COPPER DAMASCENE PROCESS FOR INTEGRATED CIRCUIT DEVICES			
Art Unit				
Examiner Name				
Attorney Docket Number	021653-000400US			

I hereby a	point:							
Practiti	Practitioners associated with the Customer Number			20350				
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Practiti	ioner(s) na	med below:				_		
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as my/our attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.								
Please recognize or change the correspondence address for the above-identified application to:								
☐ The address associated with the above-mentioned Customer Number:								
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☐ The add	ress assoc	iated with Customer Number:	· ·					
OF	OR .							
Firm or Individual Name								
Address								
Address								
City			State		ZIP			
Country								
Telephone		·	Fax					
I am the:								
☐ Applic	cant/Invent	or.						
		ord of the entire interest. See 37 CFR 3 37 CFR 3.73(b) is enclosed. (Form PT).				
		SIGNATURE of Applic	ant or A	ssignee of Recor	rd			
Name	Mi	chelle Gon						
Signature		may U. Gre	<u>_</u>					
Date		15/2rox		Telephone				
NOTE: Signatures of all the inventors or assignees of record of the entire interest or their representative(s) are required. Submit multiple forms if more than one signature is required, see below*.								
☐ *Total o		forms are submitted.						

STATEMENT UNDER 37 CFR 3.73(b)							
Applicant/Patent Owner: Chi Hong Pai et al.							
Application No./Patent No.: / Filed/Issue Date: /							
Entitled: <u>METHOD AND STRUCTURE TO FORM CAPACITOR IN COPPER DAMASCENE PROCESS FOR INTEGRATED CIRCUIT DEVICES</u>							
Semiconductor Manufacturing International (Shanghai) Corporation, a corporation organized under the laws of the PROC (Name of Assignee) (Type of Assignee, e.g., corporation, partnership, university, etc.)							
states that it is:							
1. the assignee of the entire right, title, and interest; or							
2. an assignee of less than the entire right, title and interest. The extent (by, percentage) of its ownership interest is% in the patent application/patent identified above by virtue of either:							
A. An assignment from the inventor(s) of the patent application/patent identified above. The assignment was recorded in the United States Patent and Trademark Office at Reel, Frame, or for which a copy thereof is attached.							
O.R.							
B. A chain of title from the inventor(s), of the patent application/patent identified above, to the current assignee as shown below:							
1. From: To :							
The document was recorded in the United States Patent and Trademark Office at Reel, Frame, or for which a copy thereof is attached.							
2. From: To :							
The document was recorded in the United States Patent and Trademark Office at Reel, Frame, or for which a copy thereof is attached.							
Additional documents in the chain of title are listed on a supplemental sheet.							
☐ Copies of assignments or other documents in the chain of title are attached. [NOTE: A separate copy (i.e., the original assignment document or a true copy of the original document) must be submitted to Assignment Division in accordance with 37 CFR Part 3, if the assignment is to be recorded in the records of the USPTO. See MPEP 302.8]							
The undersigned (whose title is supplied below) is authorized to act on behalf of the assignee.							
1/5/2014 Michelle Gon							
Date Typed or printed name							
Telephone number Signature Cheif Legal officer Title							
60100313 v1							

Attorney Docket No.: 021653-000400US

Client Reference No.: I-02-023

ASSIGNMENT OF PATENT APPLICATION

SOLE

WHEREAS, Chi Hong Pai of 18 Zhang Jiang Road, Pudong New Area, Shanghai, 201203 People's Republic of China, hereinafter referred to as "Assignor," is the inventor of the invention described and set forth in the below-identified application for United States Letters Patent:

Title of Invention:

METHOD AND STRUCTURE TO FORM CAPACITOR IN COPPER DAMASCENE PROCESS FOR INTEGRATED

CIRCUIT DEVICES

Date(s) of execution of Declaration:

Filing Date:

Application No.:

WHEREAS, Semiconductor Manufacturing International (Shanghai) Corporation, a corporation organized under the laws of the People's Republic of China, located at 18 Zhang Jiang Rd., Pudong New Area, Shanghai, 201203, People's Republic of China, hereinafter referred to as "ASSIGNEE," is desirous of acquiring an interest in the invention and application and in any U.S. Letters Patent and Registrations which may be granted on the same;

For good and valuable consideration, receipt of which is hereby acknowledged by Assignor, Assignor has assigned, and by these presents does assign to Assignee all right, title and interest in and to the invention and application and to all foreign counterparts (including patent, utility model and industrial designs), and in and to any Letters Patent and Registrations which may hereafter be granted on any patent application claiming priority from the same in the United States and all countries throughout the world, and to claim the priority from the application as provided by the Paris Convention. The right, title and interest is to be held and enjoyed by Assignee and Assignee's successors and assigns as fully and exclusively as it would have been held and enjoyed by Assignor had this Assignment not been made, for the full term of any Letters Patent and Registrations which may be granted thereon, or of any division, renewal, continuation in whole or in part, substitution, conversion, reissue, prolongation or extension thereof.

Assignor further agrees that Assignor will, without charge to Assignee, but at Assignee's expense, (a) cooperate with Assignee in the prosecution of U.S. Patent applications and foreign counterparts on the invention and any improvements, (b) execute, verify, acknowledge and deliver all such further papers, including applications and instruments of transfer, and (c) perform such other acts as Assignee lawfully may request to obtain or maintain Letters Patent and Registrations for the invention and improvements in any and all countries, and to vest title thereto in Assignee, or Assignee's successors and assigns.

Assignor hereby authorizes and requests Townsend and Townsend and Crew LLP, Two Embarcadero Center, Eighth Floor, San Francisco, CA 94111-3834, to insert herein above the application number and filing date of said application when known.

IN TESTIMONY WHEREOF, Assignor has signed his/her name on the date indicated.

60100073 v1